



TFW 2877

PTO/SB/21 (09-04)

## TRANSMITTAL FORM

(to be used for all correspondence after initial filing)

Total Number of Pages in This Submission

5

Application Number

10/081,385

Filing Date

February 20, 2002

First Named Inventor

Hirose, Takenori

Art Unit

2877

Examiner Name

Hwa S. Lee

Attorney Docket Number

16869P-042900US

### ENCLOSURES (Check all that apply)



Fee Transmittal Form



Fee Attached



Amendment/Reply (4pp)



After Final



Affidavits/declaration(s)



Extension of Time Request



Express Abandonment Request



Information Disclosure Statement



Certified Copy of Priority Document(s)



Reply to Missing Parts/ Incomplete Application



Reply to Missing Parts under 37 CFR 1.52 or 1.53



Drawing(s)



Licensing-related Papers



Petition



Petition to Convert to a Provisional Application



Power of Attorney, Revocation Change of Correspondence Address



Terminal Disclaimer



Request for Refund



CD, Number of CD(s) \_\_\_\_\_



Landscape Table on CD



After Allowance Communication to TC



Appeal Communication to Board of Appeals and Interferences



Appeal Communication to TC (Appeal Notice, Brief, Reply Brief)



Proprietary Information



Status Letter



Other Enclosure(s) (please identify below):

Return Postcard

Remarks

The Commissioner is authorized to charge any additional fees to Deposit Account 20-1430.

### SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT

Firm Name

Townsend and Townsend and Crew LLP

Signature

*Jes Del Castillo*

Printed name

Jesus Del Castillo

Date

August 17, 2006

Reg. No.

51,604

### CERTIFICATE OF TRANSMISSION/MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on the date shown below.

Signature

*Gloria Skora*

Typed or printed name

Gloria Skora

Date

August 17, 2006



PATENT

Attorney Docket No.: 16869P-042900US

Client Ref. No.: 210000749US1

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of:

Takenori HIROSE, et al.

Application No.: 10/081,385

Filed: February 20, 2002

For: FILM THICKNESS MEASURING  
METHOD AND APPARATUS, AND THIN  
FILM DEVICE MANUFACTURING  
METHOD AND MANUFACTURING  
APPARATUS USING SAME

Customer No.: 20350

Confirmation No. 9702

Examiner: Hwa S. Lee

Technology Center/Art Unit: 2877

RESPONSE TO RESTRICTION  
REQUIREMENT and AMENDMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

August 17, 2006

Sir:

In response to the Restriction Requirement mailed July 20, 2006, applicants elect to prosecute the claims of **species c.**, the invention drawn to measuring thin film thickness by determining measuring points. Accordingly, please enter the following amendments and remarks:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 4 of this paper.